

PRODUCTION QUALITY WAFER PROCESSING EQUIPMENT

LEARN MORE!



Standard Process Modules

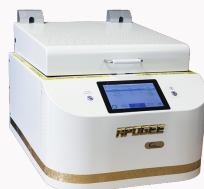
Configurations are available to accommodate very small to very large substrates

The Cee® suite of wafer processing equipment is a complete system for developing production quality processes in R&D, laboratory, or low-volume production environments.

PRODUCT OFFERINGS

BAKE

Cee® Apogee® bake plates offer robust process control, exceptional reliability, and unrivaled thermal uniformity and accuracy, edge-to-edge and wafer-to-wafer.



SPIN COAT

Cee® Apogee® spin coaters feature high spin speed resolution, providing consistent, reliable results the first time, every time.



DEVELOP/CLEAN

Cee® Apogee® spin developers deliver desired performance and control resulting in repeatable, complete, spin developing process after process.



CONTACT US TODAY



+ 1 (573) 466-4300



6 Industrial Drive
St. James, MO 65559



sales@costeffectiveequipment.com